Docket No.: 28569/38510A
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Mingming Fang et al.

Application No.: 10/713,709	Confirmation No.: 2098
Filed: November 14, 2003	Art Unit: 1764
For: CHEMICAL-MECHANICAL POLISHING (CMP) SLURRY AND METHOD OF PLANARIZING COMPUTER MEMORY DISK SURFACES	Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).\

A copy of references other than US listed on the PTO/SB/08 is attached.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 13-2855, under Order No. 28569/38510A. A duplicate copy of this paper is enclosed.

Dated: February 22, 2005   Respectfully submitted,

By _Richard H. Anderson_

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Substitute for form 1449A/B/PTO	Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT *(Use as many sheets as necessary)*	Application Number	10/713,709-Conf. #2098
	Filing Date	November 14, 2003
	First Named Inventor	Mingming Fang
	Art Unit	1764
	Examiner Name	Not Yet Assigned
Sheet 1 of 1	Attorney Docket Number	28569/38510A

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Document Number Number-Kind Code[2] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		*US-5,340,370-A1	08-23-1994	Cadien et al.	
		*US-5,527,423-A1	08-18-1996	Neville et al.	
		*US-5,622,525-A1	04-22-1997	Haisma et al.	
		*US-5,669,942-A	09-23-1997	D. K. McCullough	

* Not provided.

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.[1]	Foreign Patent Document Country Code[3]-Number[4]-Kind Code[5] (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T[6]
		EP-0 103 085-A1	03-21-1984			
		WO-02/024759-A2	03-28-2002			
		WO-03/064551-A1	08-07-2003			
		WO-2004/063301-A1	07-29-2004			
		WO-2004/083328-A2	09-30-2004			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. [1] Applicant's unique citation designation number (optional). [2] See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. [3] Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). [4] For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. [5] Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. [6] Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.[1]	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T[2]

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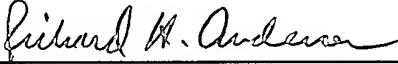| Examiner Signature		Date Considered	

Application No. (if known): 10/713,709   Attorney Docket No.: 28569/38510A

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IDS (Citation) by Applicant (4 References) (1 page)
Information Disclosure Statement